



# OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

## Supplemental Application Data Sheet

### Application Information

Application Type:: Regular  
Subject Matter:: Utility  
CD-ROM or CD-R:: None  
Title:: MALEIC ACID AND ETHYLENE UREA  
CONTAINING FORMULATION FOR REMOVING  
RESIDUE FROM SEMICONDUCTOR  
SUBSTRATE AND METHOD FOR CLEANING  
WAFER  
Attorney Docket Number:: 117641  
Suggested Drawing Figure::  
Total Drawing Sheets::  
Small Entity:: No

### Applicant Information

Applicant Authority type:: Inventor  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Tomoe  
Family Name:: MIYAZAWA  
City of Residence:: Funabashi-shi  
Country of Residence:: JAPAN

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Applicant Authority type:: Inventor  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Yoichiro  
Family Name:: FUJITA  
City of Residence:: Funabashi-shi  
Country of Residence:: JAPAN

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Applicant Authority type:: Inventor  
Primary Citizenship Country:: Japan

Status:: Full Capacity  
Given Name:: Ichiro  
Family Name:: KOBAYASHI  
City of Residence:: Chiyoda-ku  
Country of Residence:: JAPAN

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#### **Correspondence Information**

Correspondence Customer Number:: 25944

<b>Assignee Information</b>	
Assignee Name::	NISSAN CHEMICAL INDUSTRIES, LTD.
Street of mailing address::	7-1, Kandanishiki-cho 3-chome, Chiyoda-ku,
City of mailing address::	Tokyo
Country of mailing address::	JAPAN
Postal or Zip Code of mailing address::	101-0054